

jc903 U.S. PTO  
09/884736  
06/19/01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Wilbur G. Catabay and )  
Wei-Jen Hsia )  
Filed: Herewith )  
Serial Number: Unknown ) Group Art Unit: Unknown  
Title: "Plasma Treatment of Low Dielectric Constant )  
Dielectric Material to Form Structures Useful )  
in Formation of Metal Interconnects and/or )  
Filled Vias for Integrated Circuit Structure" ) Examiner: Unknown

FIRST INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.56

Honorable Commissioner of Patents  
and Trademarks  
Washington, D.C. 20231

Date: June 19, 2001

Sir:

Pursuant to 37 CFR 1.56, Applicants hereby submit the references listed on the attached form PTO-1449 (modified), which may be relevant to this case. References AB-AF are issued patents assigned to the Assignee of this patent application. Copies of each of the references are enclosed.

Respectfully submitted,

By: John P. Taylor  
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SECOND INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.56

Honorable Commissioner of Patents  
and Trademarks  
Washington, D.C. 20231

Date: June 19, 2001

Sir:

Pursuant to 37 CFR 1.56, Applicants hereby submit the references listed on the attached form PTO-1449 (modified), which were previously cited by the USPTO in Office Actions for other patent applications involving low k dielectric material. Copies of each of the references are enclosed.

Respectfully submitted,

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